	Application No.	Applicant(s)	
Notice of Allowability	10/621,863	LI ET AL.	
	Examiner	Art Unit	
	Hsien-Ming Lee	2823	
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to <u>9/2/04</u> .			
2. The allowed claim(s) is/are <u>1-3,5-11,13-18 and 20</u> .			
3. The drawings filed on are accepted by the Examine	r.		
<ul> <li>4.  ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). <ul> <li>a) ☐ All ☐ b) ☐ Some* c) ☐ None of the:</li> <li>1. ☐ Certified copies of the priority documents have been received.</li> <li>2. ☐ Certified copies of the priority documents have been received in Application No</li> <li>3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul> </li> <li>Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.</li> <li>5. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.</li> <li>6. ☑ CORRECTED DRAWINGS (as "replacement sheets") must be submitted.  (a) ☑ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached  1) ☐ hereto or 2) ☑ to Paper No./Meil Date</li></ul>			
attached Examiner's comment regarding REQUIREMENT  Attachment(s)  1. □ Notice of References Cited (PTO-892)	FOR THE DEPOSIT OF BIOLOGICA  5. □ Notice of Informal P		O-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary	•	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Dat 08), 7. ⊠ Examiner's Amendr	·	
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stateme	ent of Reasons for Allo	owance
of Biological Material	9. Other		
	HS PRIM	HARY EXAMINER	JS <sup>i</sup>
		10/28	hu

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## **DETAILED ACTION**

## Remarks

1. The objection is withdrawn.

## Examiner's Amendment

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with David C. Ripma (Reg. No. 27,672) on Oct. 21, 2004.

3. The application has been amended as follows:

In claim 1, at line 6, insert -- depositing a layer of oxide, -- after "drain;."

In claim 5, at line 4 and claim 11, at line 4, replace "other layer" with -- another layer --.

## Allowable Subject Matter

- 4. Claims 1-3, 5-11, 13-18 and 20 are allowed.
- 5. The following is an examiner's statement of reasons for allowance:

The prior art of record at least neither teaches nor suggests threshold adjustment ion Implantation and annealing precedes the plasma space etching

6. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hsien-Ming Lee whose telephone number is 571-272-1863. The examiner can normally be reached on Tuesday-Thursday ( $8:00 \sim 6:00$ ).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hsien-Ming Lee Primary Examiner Art Unit 2823

Oct. 28, 2004

HSIEN-MING LEE
PRIMARY EXAMINER
10/18/204